

Docket No.: 50389-052

PATENT**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of

Chihiro KAWAI, et al.

Serial No.:

Group Art Unit:

Filed: July 08, 2004

Examiner:

For: POROUS SEMICONDUCTOR AND METHOD FOR MANUFACTURING SAME

**PRELIMINARY AMENDMENT**

Mail Stop Preliminary Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-referenced application, please amend the application as follows: